

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18 Stylesheet Version v18.0

> Title of Invention

Method of Ion Implantation for Achieving Desired Dopant Concentration

Application Number:

10/619058

6891

Confirmation Number: First Named Applicant:

Paul Layman

Attorney Docket Number: 075903-248

Art Unit:

2821 2823

Search string:

(4042843 or 5372957 or 6281558 or 6020244

or 5841170 or 6297098 or 6524903 or 4315781 or 5362981 or 5589410 or 5827763 or 6187619

or 6153454 or 5817551 or 6163053 or 20020019103 or 20020036328 or

20020005553).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
Te	1	4042843	1977-08-16	Sikes		•	
	2	5372957	1994-12-13	Liang, et al			
	3	6281558	2001-08-28	Sayama, et al			
	4	6020244	2000-02-01	Thompson, et al			
	5	5841170	1998-11-24	Adan, et al			
	6	6297098	2001-10-02	Lin, et al			
	7	6524903	2003-02-25	Ootsuka, et al			
	8	4315781	1982-02-16	Henderson			
	9	5362981	1994-11-08	Sato, et al			
	10	5589410	1996-12-31	Sato, et al			
	11	5827763	1998-10-27	Gardner, et al			
	12	6187619	2001-02-13	Wu			
	13	6153454	2000-11-28	Krivokapic			
	14	5817551	1998-10-06	Fujii, et al			
17.	15	6163053	2000-12-19	Kawashima			

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paper NO: 111103

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US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	. 1	20020019103	2002-02-14	Lin, et al]		
	2 ·	20020036328	2002-03-28	Richards, et al]		
	3	20020005553	2002-01-17	Ootsuka, et al]	•	•

Signature

Examiner Name	Date
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